



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of )  
Shinji NAKAMURA et al. )  
Japanese Priority Application No. 11-285582 ) Attn: Applications  
Japanese Priority Date: October 6, 1999 ) Branch  
For: SEMICONDUCTOR DEVICE, )  
SEMICONDUCTOR SUBSTRATE, )  
AND MANUFACTURE METHOD ) Date: October 5, 2000

INFORMATION DISCLOSURE STATEMENT  
AND NOTIFICATION OF RELATED APPLICATIONS

Honorable Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

At least some of the references listed on the attached Form PTO-1449 are discussed in the specification of the subject application.

Copies of these references are submitted herewith in accordance with 37

C.F.R. 1.98(a).

The attention of the Examiner is directed to Japanese Patent Laid-Open Publication No. 2000-156524 which corresponds to EP Publication No. EP 0 993 048 A2 and corresponding Application Serial No. 09/395,261 filed on September 14, 1999.

Respectfully submitted,



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Eric J. Robinson  
Registration No. 38,285

NIXON PEABODY LLP  
8180 Greensboro Drive, Suite 800  
McLean, Virginia 22102  
(703) 790-9110